

Shu Yang

List of Publications by Year in descending order

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83
papers

3,630
citations

172457

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155660

55
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84
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docs citations

84
times ranked

2545
citing authors

#	ARTICLE	IF	CITATIONS
1	Low ON-Resistance Fully-Vertical GaN-on-SiC Schottky Barrier Diode with Conductive Buffer Layer. , 2022, , .		1
2	1 MHz 48â€“12 V Regulated DCX With Single Transformer. IEEE Journal of Emerging and Selected Topics in Power Electronics, 2021, 9, 38-47.	5.4	20
3	Conductivity Modulation in Vertical GaN PiN Diode: Evidence and Impact. IEEE Electron Device Letters, 2021, 42, 300-303.	3.9	19
4	The Safe Operating Area of AlGaIn/GaN-Based Sensor. IEEE Sensors Journal, 2021, 21, 6241-6247.	4.7	3
5	Investigation on Thermal Resistance and Capacitance Characteristics of a Highly Integrated Power Control Unit Module. Electronics (Switzerland), 2021, 10, 958.	3.1	0
6	Low limit of detection of the AlGaIn/GaN-based sensor by the Kelvin connection detection technique. Microsystems and Nanoengineering, 2021, 7, 51.	7.0	9
7	Evaluation of Semicircular Bend Geometric Properties for Asphalt Concrete Testing. Journal of Materials in Civil Engineering, 2021, 33, 04021342.	2.9	0
8	Vertical GaN power rectifiers: interface effects and switching performance. Semiconductor Science and Technology, 2021, 36, 024005.	2.0	5
9	High-Temperature Characterization of a 1.2-kV SiC MOSFET Using Dynamic Short-Circuit Measurement Technique. IEEE Journal of Emerging and Selected Topics in Power Electronics, 2020, 8, 215-222.	5.4	19
10	Negative Dynamic RON in Vertical GaN PiN Diode: The Impact of Conductivity Modulation. , 2020, , .		1
11	UIS Withstanding Capability of GaN E-HEMTs with Schottky and Ohmic p-GaN contact. , 2020, , .		4
12	Investigation of Temperature-Dependent Dynamic R_{ON} of GaN HEMT with Hybrid-Drain under Hard and Soft Switching. , 2020, , .		14
13	Design and Optimization of Vertical GaN PiN Diodes With Fluorine-Implanted Termination. IEEE Journal of the Electron Devices Society, 2020, 8, 241-250.	2.1	4
14	The Leakage Mechanism of the Package of the AlGaIn/GaN Liquid Sensor. Materials, 2020, 13, 1903.	2.9	6
15	Thermal Resistance and Capacitance Characteristics of A 4-in-1 Integrated Power Control Unit (PCU) Module for Hybrid Electrical Vehicle (HEV). , 2020, , .		0
16	Dynamic on-State Resistance Test and Evaluation of GaN Power Devices Under Hard- and Soft-Switching Conditions by Double and Multiple Pulses. IEEE Transactions on Power Electronics, 2019, 34, 1044-1053.	7.9	126
17	Surge Current Capability of GaN E-HEMTs in Reverse Conduction Mode. , 2019, , .		5
18	Investigation of Surge Current Capability of GaN E-HEMTs in The Third Quadrant: The Impact of P-GaN Contact. IEEE Journal of Emerging and Selected Topics in Power Electronics, 2019, 7, 1465-1474.	5.4	13

#	ARTICLE	IF	CITATIONS
19	Design and Characterization of Area-Efficient Trench Termination for 4H-SiC Devices. IEEE Journal of Emerging and Selected Topics in Power Electronics, 2019, 7, 1519-1526.	5.4	6
20	Optimization of gate geometry towards high-sensitivity AlGaIn/GaN pH sensor. Talanta, 2019, 205, 120134.	5.5	22
21	Fluorine-Implanted Termination for Vertical GaN Schottky Rectifier With High Blocking Voltage and Low Forward Voltage Drop. IEEE Electron Device Letters, 2019, 40, 1040-1043.	3.9	61
22	Dynamic On-Resistance in GaN Power Devices: Mechanisms, Characterizations, and Modeling. IEEE Journal of Emerging and Selected Topics in Power Electronics, 2019, 7, 1425-1439.	5.4	85
23	Photon-Enhanced Conductivity Modulation and Surge Current Capability in Vertical GaN Power Rectifiers. , 2019, , .		17
24	High-resolution separation of DNA/proteins through nanorod sieving matrix. Biosensors and Bioelectronics, 2019, 137, 8-14.	10.1	3
25	Correction to "Trench Termination With SiO ₂ -Encapsulated Dielectric for Near-Ideal Breakdown Voltage in 4H-SiC Devices" [Dec 18 1900-1903]. IEEE Electron Device Letters, 2019, 40, 353-353.	3.9	0
26	Current-Collapse-Free and Fast Reverse Recovery Performance in Vertical GaN-on-GaN Schottky Barrier Diode. IEEE Transactions on Power Electronics, 2019, 34, 5012-5018.	7.9	56
27	High-Voltage and High- $I_{\text{ON}}/I_{\text{OFF}}$ Vertical GaN-on-GaN Schottky Barrier Diode With Nitridation-Based Termination. IEEE Electron Device Letters, 2018, 39, 572-575.	3.9	105
28	The 2018 GaN power electronics roadmap. Journal Physics D: Applied Physics, 2018, 51, 163001.	2.8	843
29	A MHz Regulated DC Transformer with Wide Voltage Range. , 2018, , .		8
30	A Wide Output LLC Converter Based on Full Bridge and Half Bridge Topology Morphing Method Using Trajectory Transition. , 2018, , .		8
31	Design of Fluorine-Ion-Based Junction Termination Extension for Vertical GaN Schottky Rectifier. , 2018, , .		0
32	Trench Termination With SiO ₂ -Encapsulated Dielectric for Near-Ideal Breakdown Voltage in 4H-SiC Devices. IEEE Electron Device Letters, 2018, 39, 1900-1903.	3.9	16
33	Photolithographic Patterning of Cytop with Limited Contact Angle Degradation. Micromachines, 2018, 9, 509.	2.9	4
34	1 kV/1.3 m ² cm ² vertical GaN-on-GaN Schottky barrier diodes with high switching performance. , 2018, , .		4
35	Characterization of 1.2 kV SiC super-junction SBD implemented by trench and implantation technique. , 2018, , .		5
36	GaN-on-Si lateral power devices with symmetric vertical leakage: The impact of floating substrate. , 2018, , .		7

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55	GaN-Based Metal-Insulator-Semiconductor High-Electron-Mobility Transistors Using Low-Pressure Chemical Vapor Deposition SiN _x as Gate Dielectric. IEEE Electron Device Letters, 2015, 36, 448-450.	3.9	84
56	Characterization of SiN _x /AlN passivation stack with epitaxial AlN grown on AlGaIn/GaN heterojunctions by plasma-enhanced atomic layer deposition. Applied Physics Express, 2015, 8, 064101.	2.4	16
57	O ₃ -sourced atomic layer deposition of high quality Al ₂ O ₃ gate dielectric for normally-off GaN metal-insulator-semiconductor high-electron-mobility transistors. Applied Physics Letters, 2015, 106, .	3.3	58
58	Characterization of Leakage and Reliability of SiN _x Gate Dielectric by Low-Pressure Chemical Vapor Deposition for GaN-based MIS-HEMTs. IEEE Transactions on Electron Devices, 2015, 62, 3215-3222.	3.0	89
59	650-V GaN-based MIS-HEMTs using LPCVD-SiN _x as passivation and gate dielectric. , 2015, , .		8
60	Mechanisms of thermally induced threshold voltage instability in GaN-based heterojunction transistors. Applied Physics Letters, 2014, 105, .	3.3	19
61	Performance enhancement of normally-off Al ₂ O ₃ /AlN/GaN MOS-Channel-HEMTs with an ALD-grown AlN interfacial layer. , 2014, , .		7
62	Substrate-Coupled Cross-Talk Effects on an AlGaIn/GaN-on-Si Smart Power IC Platform. IEEE Transactions on Electron Devices, 2014, 61, 3808-3813.	3.0	32
63	Thermally induced threshold voltage instability of III-Nitride MIS-HEMTs and MOSC-HEMTs: Underlying mechanisms and optimization schemes. , 2014, , .		28
64	Nitridation interfacial-layer technology: Enabling low interface trap density and high stability in III-nitride MIS-HEMTs. , 2014, , .		0
65	Investigation of buffer traps in AlGaIn/GaN-on-Si devices by thermally stimulated current spectroscopy and back-gating measurement. Applied Physics Letters, 2014, 104, .	3.3	50
66	GaN-to-Si vertical conduction mechanisms in AlGaIn/GaN lateral heterojunction FET structures. Physica Status Solidi C: Current Topics in Solid State Physics, 2014, 11, 949-952.	0.8	17
67	High- f_{MAX} High Johnson's Figure-of-Merit 0.2- μm Gate AlGaIn/GaN HEMTs on Silicon Substrate With AlN/SiN_x Passivation. IEEE Electron Device Letters, 2014, 35, 315-317.	3.9	50
68	Al ₂ O ₃ /AlN/GaN MOS-Channel-HEMTs With an AlN Interfacial Layer. IEEE Electron Device Letters, 2014, 35, 723-725.	3.9	104
69	Fabrication and Characterization of Enhancement-Mode High- κ -AlGaIn/GaN MIS-HEMTs. IEEE Transactions on Electron Devices, 2013, 60, 3040-3046.	3.0	46
70	Monolithically integrated 600-V E/D-mode SiN _x /AlGaIn/GaN MIS-HEMTs and their applications in low-standby-power start-up circuit for switched-mode power supplies. , 2013, , .		1
71	Mapping of interface traps in high-performance Al ₂ O ₃ /AlGaIn/GaN MIS-heterostructures using frequency- and temperature-dependent C-V techniques. , 2013, , .		32
72	Mechanism of PEALD-Grown AlN Passivation for AlGaIn/GaN HEMTs: Compensation of Interface Traps by Polarization Charges. IEEE Electron Device Letters, 2013, 34, 193-195.	3.9	110

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73	600-V Normally Off $\text{SiN}_x/\text{AlGaIn}/\text{GaIn}$ MIS-HEMT With Large Gate Swing and Low Current Collapse. IEEE Electron Device Letters, 2013, 34, 1373-1375.	3.9	223
74	Enhancement-Mode $\text{LaLuO}_3/\text{AlGaIn}/\text{GaIn}$ Metal-Insulator-Semiconductor High-Electron-Mobility Transistors Using Fluorine Plasma Ion Implantation. Japanese Journal of Applied Physics, 2013, 52, 08JN02.	1.5	5
75	Characterization of VT-instability in enhancement-mode $\text{Al}_2\text{O}_3/\text{AlGaIn}/\text{GaIn}$ MIS-HEMTs. Physica Status Solidi C: Current Topics in Solid State Physics, 2013, 10, 1397-1400.	0.8	66
76	High-Quality Interface in $\text{Al}_2\text{O}_3/\text{GaIn}/\text{AlGaIn}/\text{GaIn}$ MIS Structures With In Situ Pre-Gate Plasma Nitridation. IEEE Electron Device Letters, 2013, 34, 1497-1499.	3.9	160
77	Effects of interface oxidation on the transport behavior of the two-dimensional-electron-gas in $\text{AlGaIn}/\text{GaIn}$ heterostructures by plasma-enhanced-atomic-layer-deposited AlN passivation. Journal of Applied Physics, 2013, 114, .	2.5	16
78	$\text{AlGaIn}/\text{GaIn}$ MISHEMTs With High- κ LaLuO_3 Gate Dielectric. IEEE Electron Device Letters, 2012, 33, 979-981.	3.9	40
79	Characterization of V_{th} -instability in $\text{Al}_2\text{O}_3/\text{GaIn}/\text{AlGaIn}/\text{GaIn}$ MIS-HEMTs by quasi-static C_V measurement. Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 923-926.	0.8	29
80	Effective Passivation of $\text{AlGaIn}/\text{GaIn}$ HEMTs by ALD-Grown AlN Thin Film. IEEE Electron Device Letters, 2012, 33, 516-518.	3.9	213
81	Characterization of high- κ LaLuO_3 thin film grown on $\text{AlGaIn}/\text{GaIn}$ heterostructure by molecular beam deposition. Applied Physics Letters, 2011, 99, 182103.	3.3	12
82	Threshold Voltage Instability in $\text{Al}_2\text{O}_3/\text{GaIn}/\text{AlGaIn}/\text{GaIn}$ Metal-Insulator-Semiconductor High-Electron Mobility Transistors. Japanese Journal of Applied Physics, 2011, 50, 110202.	1.5	79
83	Threshold Voltage Instability in $\text{Al}_2\text{O}_3/\text{GaIn}/\text{AlGaIn}/\text{GaIn}$ Metal-Insulator-Semiconductor High-Electron Mobility Transistors. Japanese Journal of Applied Physics, 2011, 50, 110202.	1.5	71